

IN THE UNITED STATES PATENT & TRADEMARK OFFICE
Group Art Unit 2814

In re
Patent Application of

HAYASHI, Yoshihiro et al.

Application No.: 10/561,089

Int'l Application No. PCT/JP2004/008450

Int'l Filing Date: 16 June 2004

Confirmation No.: 2457

Filing Date: 12/16/2005

Examiner: Long Pham

“SEMICONDUCTOR DEVICE AND A
METHOD FOR FORMING THE SAME”

Atty Reference: 201558-9001

Electronically filed by:

/elizabeth m. campbell tressler/

November 25, 2009
Date

AMENDMENT AND RESPONSE TO OFFICE ACTION

MAIL STOP: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This communication is in response to the Office Action mailed June 26, 2009, and is filed with a request for a two-month extension of time and the requisite fee. Please charge or credit Deposit Account No. 50-1965 with any deficiency or overpayment of fees associated with the filing of this Response. Please note that the Response contains the following sections:

Listing of the Claims begins on page 2.

Remarks begin on page 4.